



Attorney Docket No.: 42.P18609

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Brask et al.

Application No.: 10/828,958

Filed: April 20, 2004

For: A METHOD FOR MAKING A SEMICONDUCTOR DEVICE HAVING A HIGH-K GATE DIELECTRIC LAYER AND A METAL GATE ELECTRODE

Examiner: Christian D. Wilson

Art Unit: 2891

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Examiner:

This is in response to the Office Action mailed November 18, 2005. Applicants respectfully request the Examiner to enter this Preliminary Amendment and consider the following remarks.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

on January 18, 2006  
Date of Deposit

Teresa Mattox  
Name of Person Mailing Correspondence

Teresa Mattox 1/18/06  
Signature Date